

JAN 26 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jin, et al.

Application No.: 10/805,718

Filed: 3/22/2004

Title: THIN FILM RESISTOR STRUCTURE AND  
METHOD FOR FORMING THIN FILM RESISTOR  
STRUCTUREArt Unit:  
2832Examiner:  
Trung Q. Dang

Attorney Docket No.: 1766A

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

O.K TO ENTER

Amendment After AllowanceT.D  
3/22/06

Dear Sir:

Applicants respectfully request that the Examiner enter the following amendment  
and consider the following remarks.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.